Docket No.: 060188-0807



PATENT

Customer Number: 20277

Osamu KUSUMOTO, et al.

Confirmation Number: 4190

Application No.: 10/801,606

Group Art Unit: 2811

Filed: March 17, 2004

In re Application of

Examiner: HU, Shouxiang

For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached: 1 Replacement Drawing Sheet (Fig. 9 Amended)

The fee has been calculated as shown below:

The fee has been calculate	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	30	30	0	\$50.00 =	\$0.00
Independent Claims	2	3	0	\$200.00 =	\$0.00
		Multiple dependent claims newly presented			\$0.00
Fee for extension of time					\$0.00
					\$0.00
		Total of Above Calculations			\$0.00

Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of 冈 extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Foga Registration No. 36,139

Please/recognize our Customer No. 20277 as our

correspondence address.

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Facsimile: 202.756.8087 Date: January 4, 2006